



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant  | : Paul B. Mirkarimi et al.   | Docket No. | : CIL-10972   |
| Serial No. | : 10/086,614   | Art Unit   | : 1762        |
| Filed      | : March 1, 2002  | Examiner   | : B. Pianalto |
| For        | : Ion-Assisted Deposition Techniques For<br>The Planarization Of Topological Defects |            |               |

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed December 9, 2003, please amend the  
above-referenced application as follows: